



GLAST Large Area Telescope Calorimeter Subsystem

5.3 CDE Manufacturing

Didier Bédérède Project Manager
Philippe Bourgeois System Engineer
CEA Saclay/ DSM/DAPNIA

didier.bederede@cea.fr
pbourgeois@cea.fr



CEA responsibilities

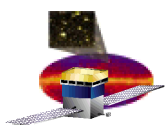
Design and development of the CDE including :

- **CDE process specification (written & sent for call for tender Feb'03)**
- **shared procurement, with the U.S., of DPDs to a common specification (1800 DPD from CEA-Hamamatsu-France proposition Mar'03)**
- **DPD testing (done for EM-DPDs)**
- **procurement of DPD wires, attachment and testing of the PDA (diode-cable assemblies),**
- **bonding of PDA to the Crystals and process qualification,**
- **procurement of wrapping material, crystal wrapping, and process qualification,**
- **acceptance testing of finished CDE**

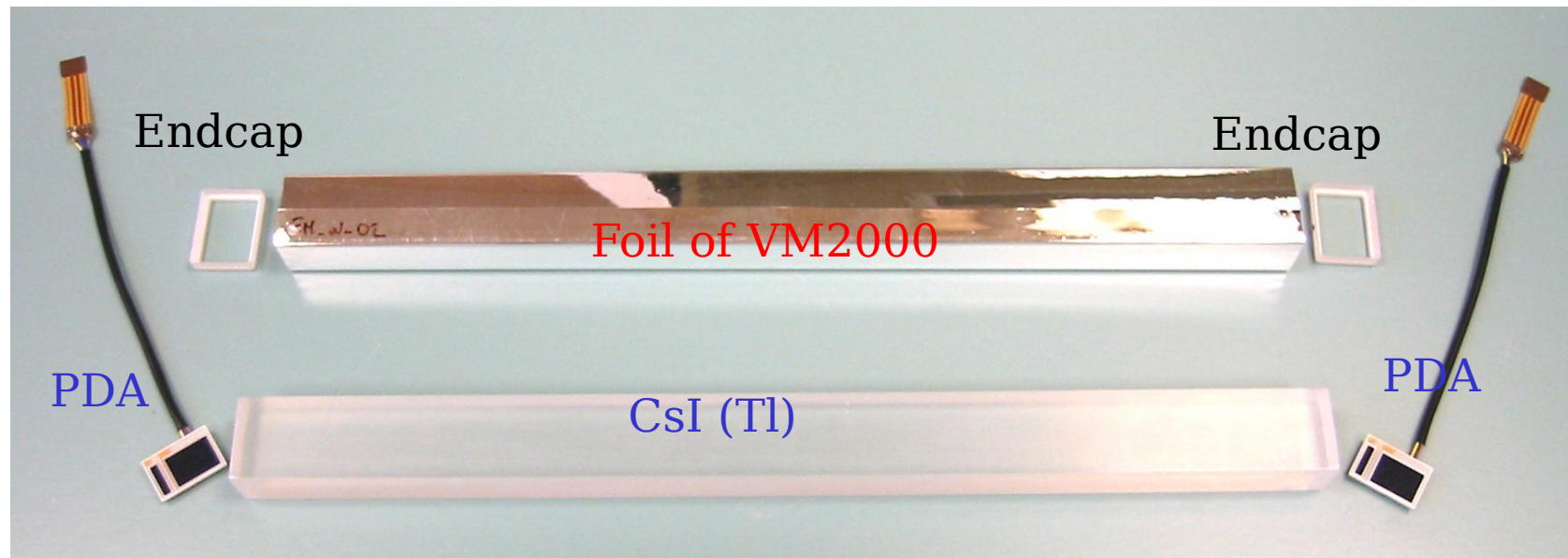


Program status

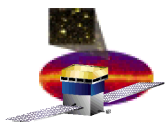
- ❑ **LoA between NASA and CNES**
 - **final draft approved by both parties, almost signed**
- ❑ **MoA between SLAC, NRL, CEA:**
 - **signed in Jan'03**
- ❑ **Financial agreement between CNES and CEA:**
 - **budget & manpower profiles approved in Nov'02**
 - **new CNES financial situation: participation to GLAST recommended to the President, but cost-capped**
- ❑ **14 EM-CDEs delivered to NRL in Dec'03**
 - **they meet the specifications & performance**
 - **bonding on DPD (epoxy window) & tooling design demonstrated**
 - **packing concept evaluated**
 - **DPD evaluation failed (epoxy window at low T + pin corrosion)**
⇒ new DPD
 - **flex changed to wires at the CAL level**
- ❑ **present activities**
 - **evaluation of the new DPD, new PDA and new PDA bonding**
 - **placing contracts for the FM PDA, CDE, GSE, & various containers**



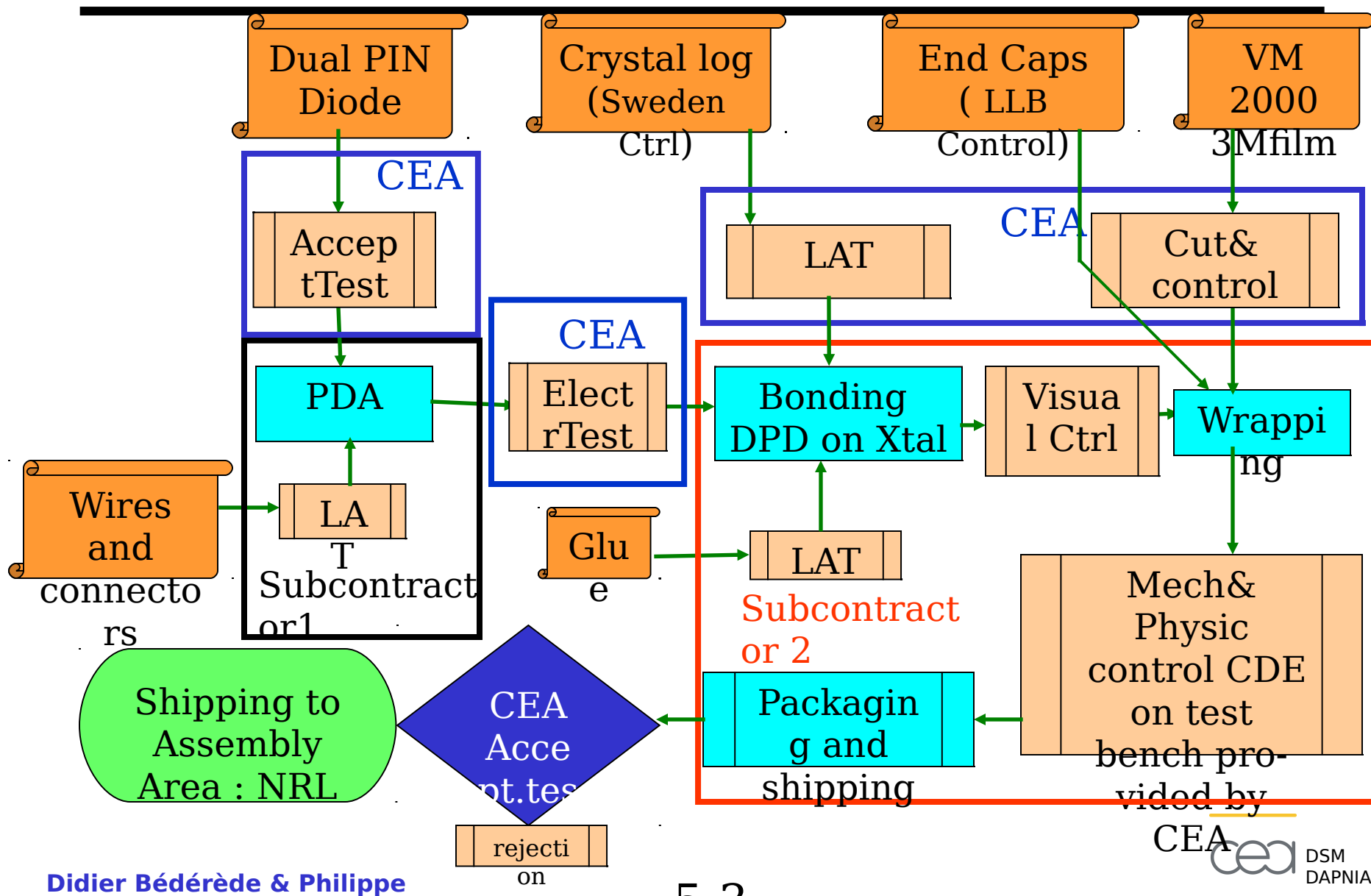
CDE Overview

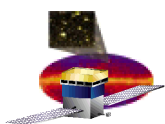


- ❑ a CDE consists of :
 - 1 cristal log of CsI doped with Thallium provided and tested by Sweden
 - 2 PDA (DPD with wires), one bonded to each end
 - wrapping consisting of one molded foil of VM2000 and 2 white endcaps provided and controlled by LLR



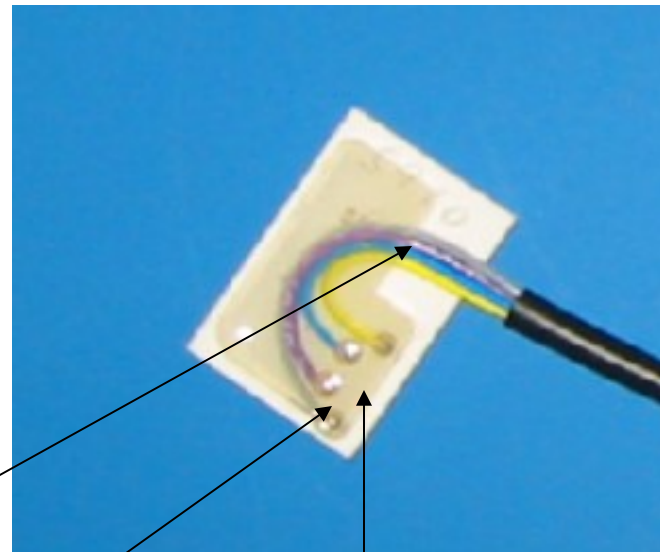
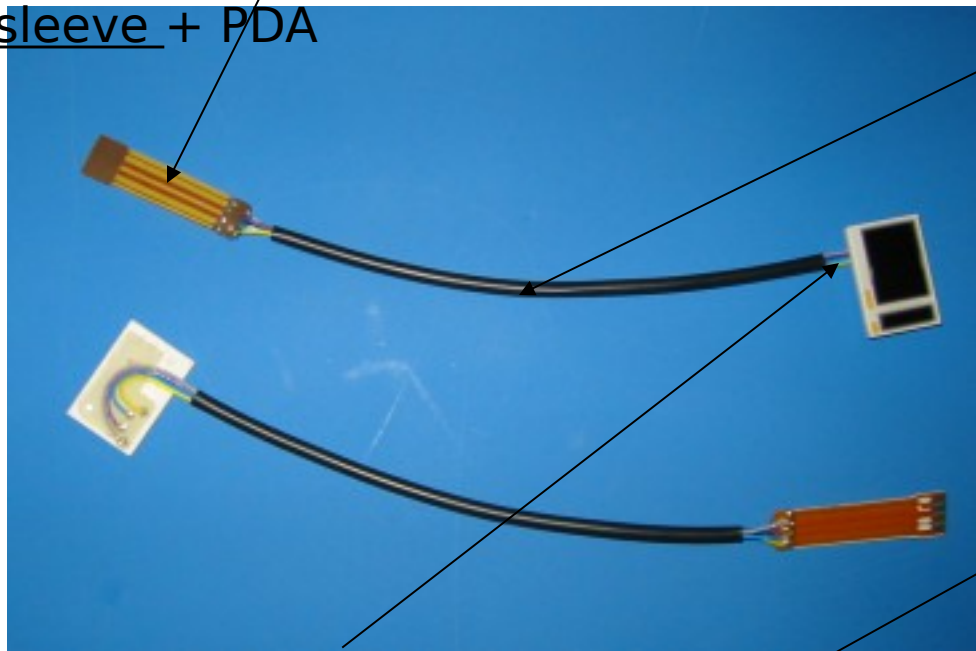
Manufacturing Plan



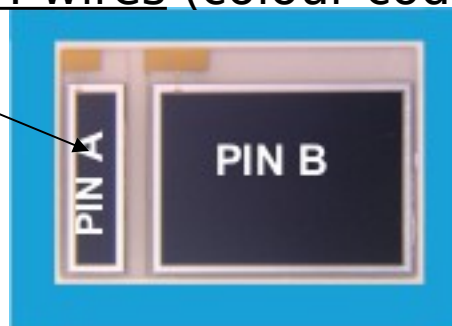


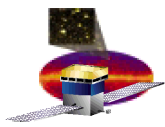
PDA overview

PDA_{fr} = Connector for all French acceptance tests + Protective sleeve + PDA



PDA = Dual Pin Diode + 4 wires (colour coded) soldered on pins + staking

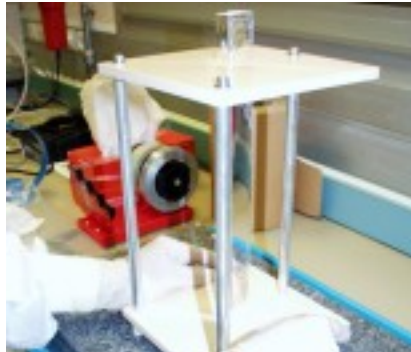




PDA manufacturing plan

- ❑ Because of the short schedule: wire procurement before contract (**> 8 weeks to manufacture**)
- ❑ Contract Order: **foreseen May 21**
 - Call for tender : **done** (6 companies interested)
 - Sending specifications to selected companies (**mid March**)
 - Answers from the companies: (**end April**)
 - Opening letters and ask for additional information
 - Write & sign the contract and place the order
- ❑ Preparation & training (molding tools, encapsulant product...)
7 weeks
- ❑ Manufacturing lot 1 of 264 PDA (**begin. July to begin. Aug**)
- ❑ Manufacturing lot 2 of 240 PDA (**in August**)
- ❑ Manufacturing lots 3 to 20 (**240 PDA /2 weeks**)

PDA-Crystal Bonding Process Overview

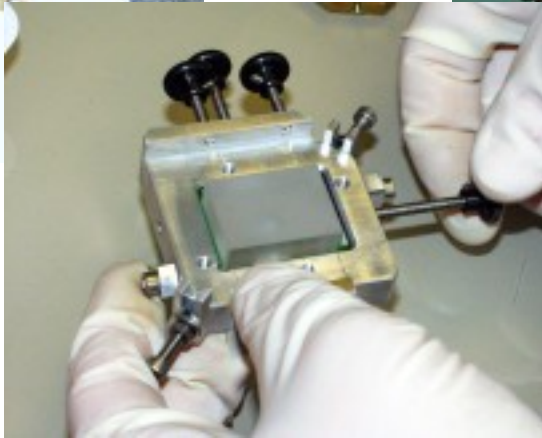


**End
face
polishin
g**

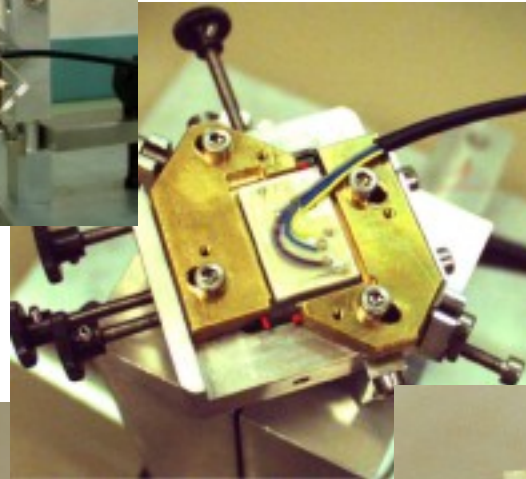


**Mold tooling & Glue
injection**

**Suppo
rt
toolin
g**



**Primer
depositi
on**



**Mold
removal
after 24
hours**



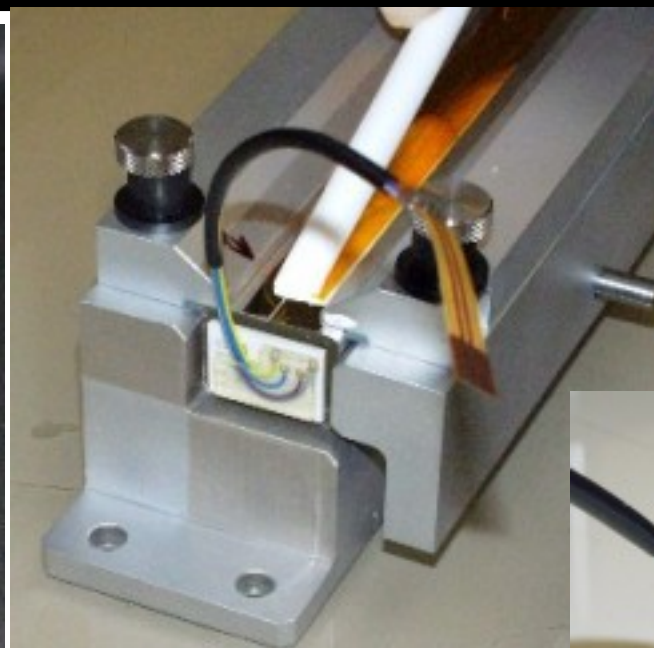
**Polymerisat
ion time = 7
days**





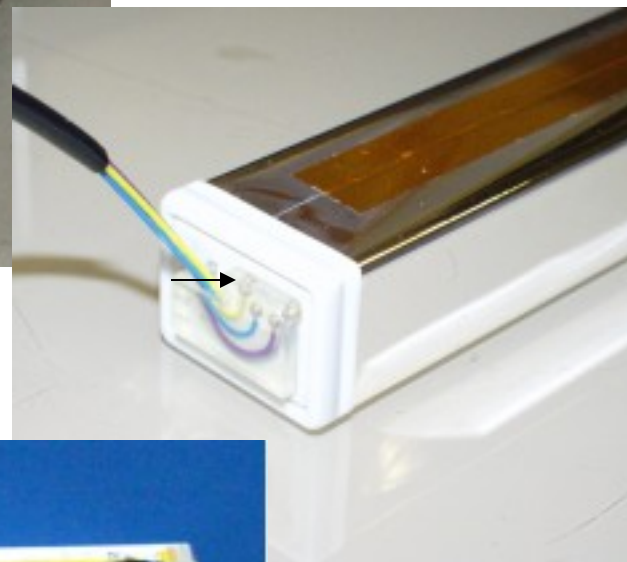
Wrapping overview

**VM2000
foil
shaped
around a
kernel at
120°C**

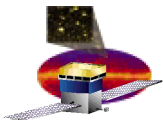


**Mounting of
the end cap**

**VM2000
foil
wrapped
and
pasted**



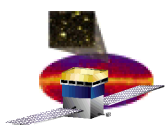
**Wrapped
CDE**



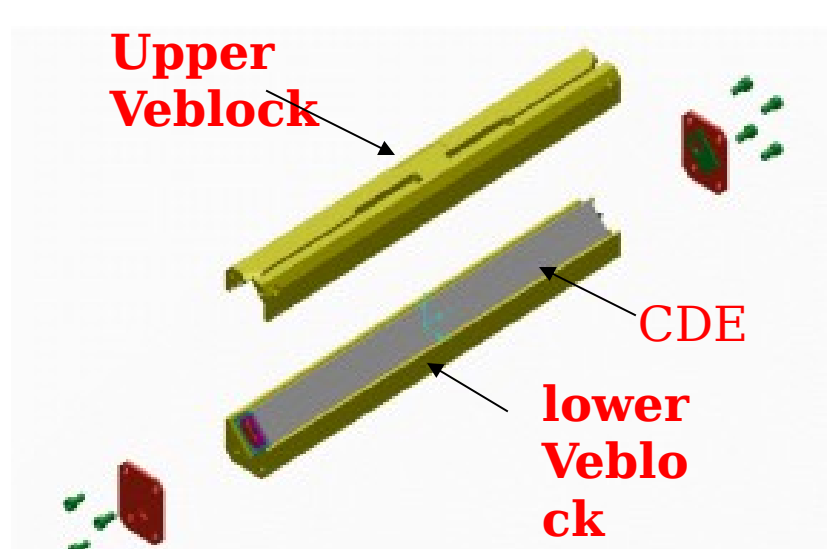
CDE manufacturing plan

- ❑ Same manufacturer does bonding & wrapping
- ❑ Order **foreseen May 26**
 - Call for tender : **done** (6 companies interested)
 - Sending specifications to selected companies: **done Feb. 13**
 - Answers from the companies: **March 28**
 - Opening letters and ask for additional information **< 2 weeks**
 - Company selection, presentation of documents to committee **on 20 May**
 - Write & sign the contract and place the order **10 days**
- ❑ Procurement of toolings to manufacture 60 CDE/week, process practice & tuning on CEA tooling, tests on mini-Xtal, tests of 12 CDE: **3 months**
- ❑ Manufacturing&acceptance lot 1: 120 CDE in 4 weeks **in Sept**
- ❑ Manufacturing&acceptance lots 2 to 17: 108 CDE/2 weeks **Mid May '04**





CDE packing & shipping





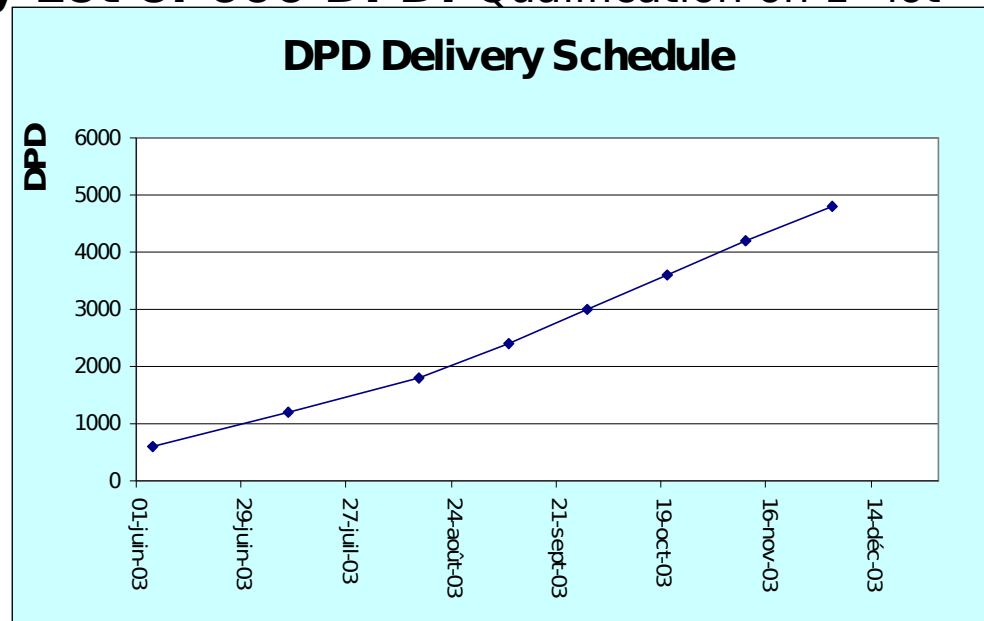
CDE System/Verification plan

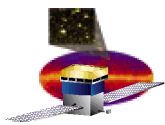
- ❑ **EVALUATION: characteristics and margin studies**
 - **DPD S8576-01 (Silicone window, Lead tinning):**
 - 11 S8576 with Silicone encapsulant
 - 184 S8576-01 (DPD pre-FM-series)
 - **PDA (solder, staking, wires):** DPD pre-series
 - **Bonding (tooling, process):** DPD pre-series + mini Xtal
- ❑ **QUALIFICATION: Specification requirements**
 - **DPD S8576-01**
 - **Tinned ceramic:** 1% by lot
 - **Die:** 5 by wafer lot
 - **Assembly:** 10% 1st Delivery Lot (+ screening)
 - **PDA (Plan TBC)**
 - **Bonding (tooling, process):** DPD pre-series + mini Xtal
 - **CDE :** DPD pre-series+ Xtal pre-series



DPD procurement status

- ❑ **New DPD version: S8576-01**
- ❑ **Order shared between NRL (5 lots) and CEA (3 lots)**
- ❑ **Order in place before evaluation (driven by schedule)**
- ❑ **Delivery of a pre-series:**
 - **184 with the silicone resin encapsulant**
 - **20 without encapsulant** (backup encapsulant study)
- ❑ **Delivery by Lot of 600 DPD:** Qualification on 1st lot





DPD Qualification plan

❑ Philosophy:

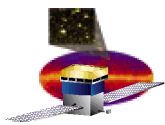
- Qualification on 1 lot associated to a screening
- Qualification on 60 of 1st Delivery Lot in addition to its Acceptance test

❑ Main tests

- Lead solderability (1 DPD)
- Moisture intake (168h, 50°C, 50%RH) (6 DPD)
- Steady-state life (1000h, 60°C) (22 DPD)
- Thermal cycle (60c, -30 to 50°C) (10 DPD)
- Radiation testing (10krad) (3 DPD)

❑ Associated control

- Dark current & Green photosensitivity
- Delamination, crack
- Destructive Physical analysis



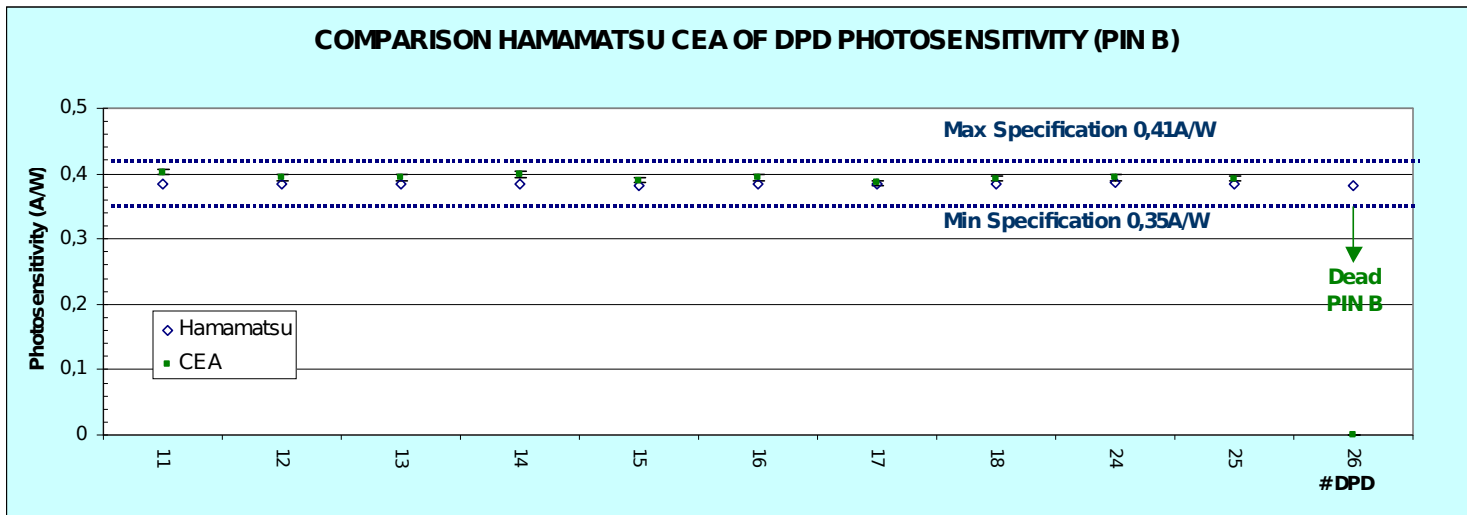
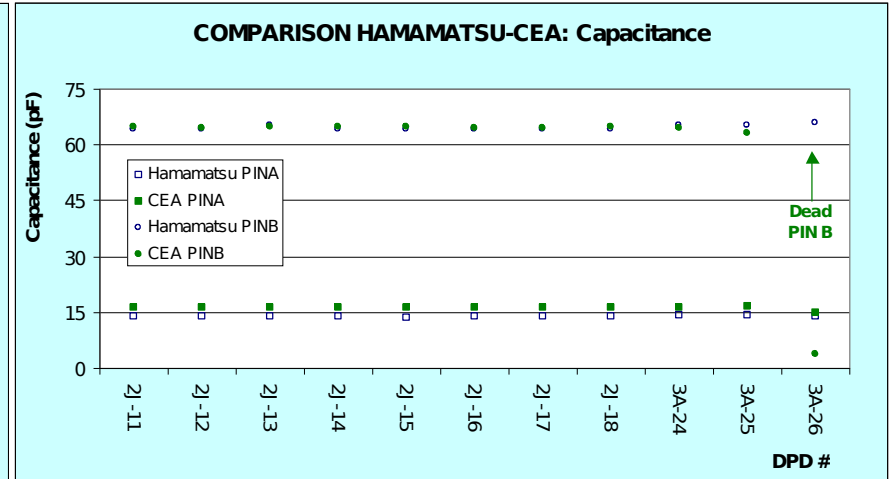
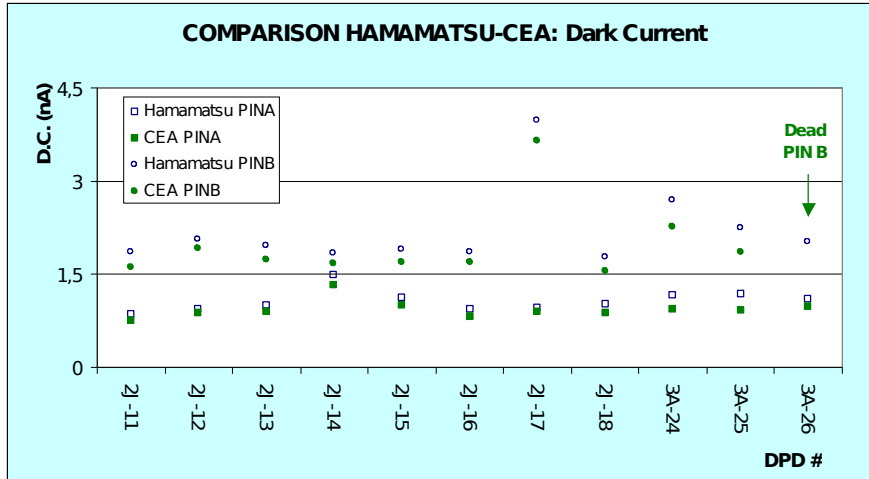
DPD Acceptance Test (1)

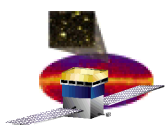
- ❑ **Receiving inspection (with Hamamatsu representative)**
 - **Packaging and sensor inspections** (shock, humidity, temp.)
 - **DPD recorded parameters vs the acceptance limits**
 - D.C., Capacitance, Sensitivity
- ❑ **Control (within 2 weeks at CEA)**
 - **100% Visual inspection** (window, leads)
 - ⇒ **refusal of bad DPDs**
 - **Sampling > 10% parameters** (D.C., Capacitance, Sensitivity)
 - ⇒ **Drift production monitoring**
 - ⇒ **Refusal of the delivery lot**



DPD Acceptance Test (2)

□ Acceptance test on the 11 DPD S8576 Silicone



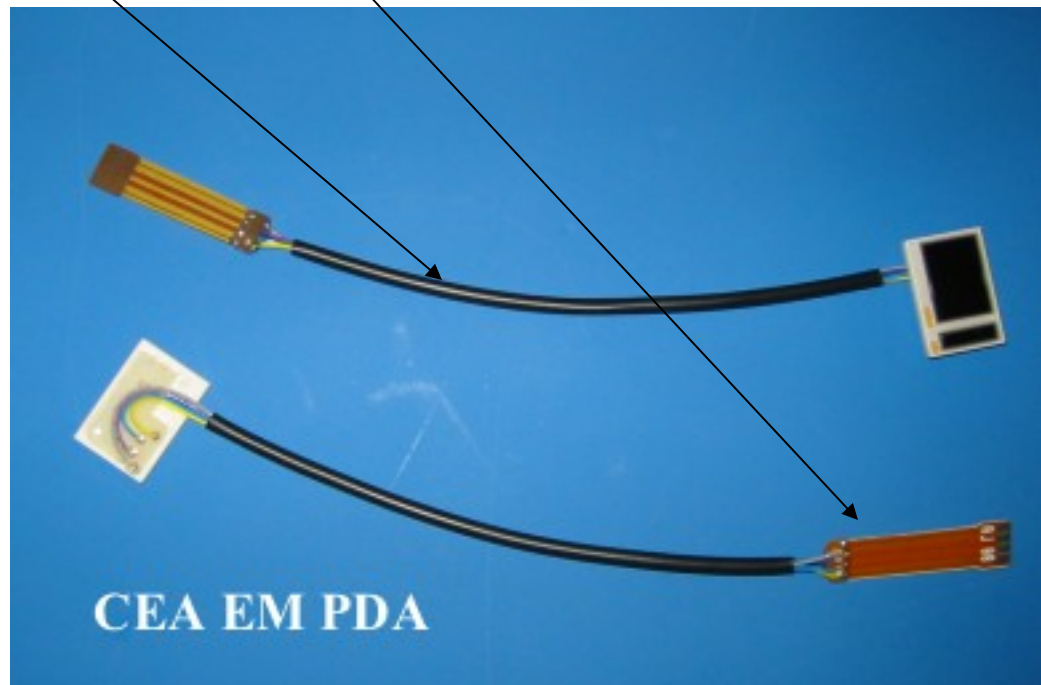
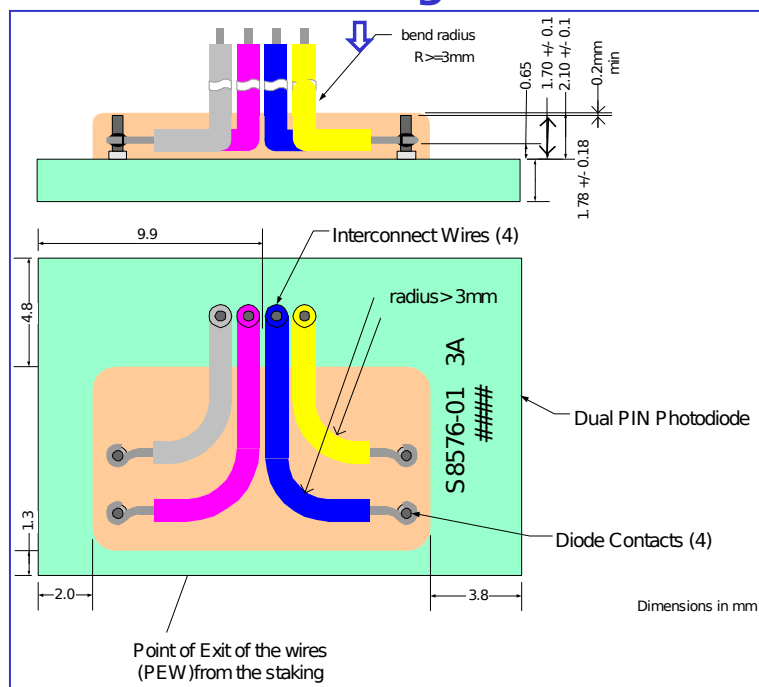


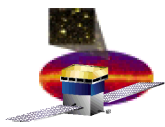
PDA design

PhotoDiode Assembly: DPD + soldered wires + wires staking on ceramic

PDAfr PDA + protective sleeve + connector for CEA test benches

New staking mold





PDA verification plan

❑ Evaluation:

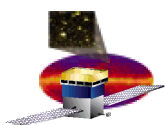
- **Strength of the soldered and staked wires** (1kg requirement)
- **New tinning (SN96Ag4 + 40°C)** study of DPD temperature when soldering
- **Insulation of the 0.2mm staking above the leads** (0.1nA)

❑ Qualification:

- **Spatial components (wires, encapsulant)**
- **Spatial approve Subcontractor**
- **Thermal cycle (60c, -30 to 50°C)** study of lead insulation on bare ceramic

❑ Acceptance test:

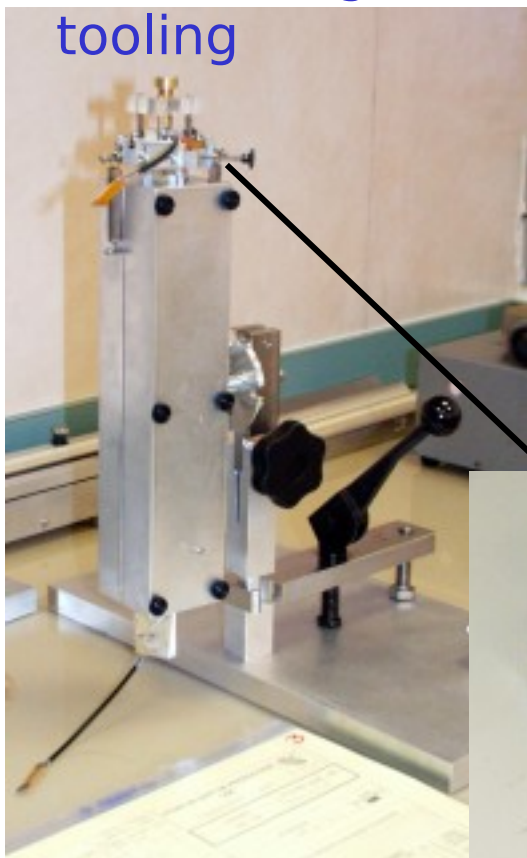
- **100% Electrical** (D.C.)
- **100% Visual** (Solder before staking, window)
- **100% go-no go staking area**
- **100% staking thickness**



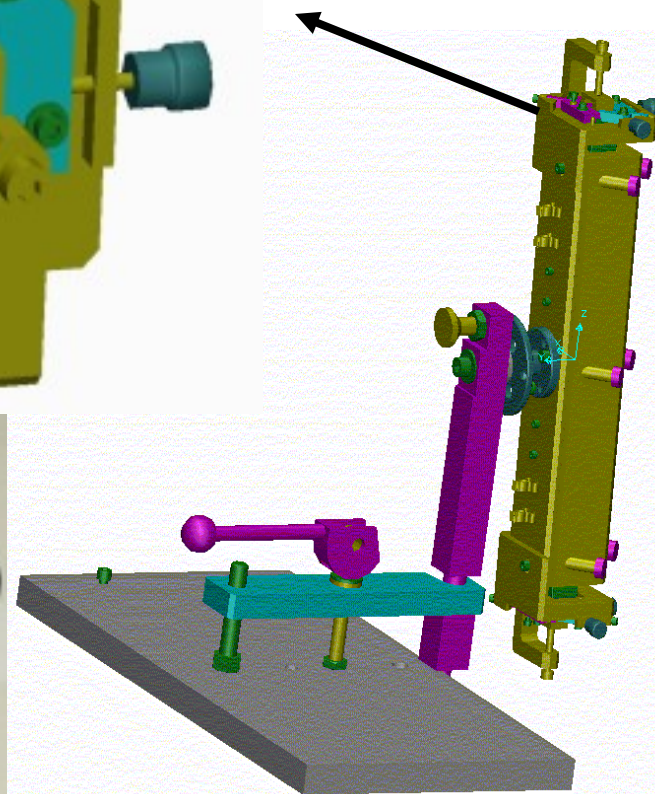
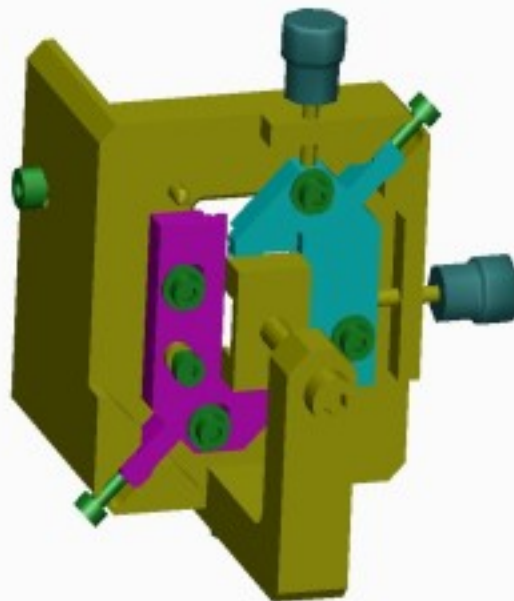
Bonding tooling design

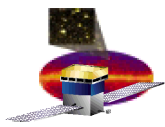
□ Upgrade of the too

EM bonding
tooling



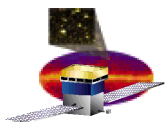
FM bonding
tooling





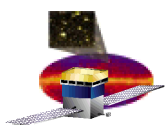
Bonding process verification

- ❑ **Sample: Mini Xtal + PDA at each end**
- ❑ **Evaluation:**
 - **Thermal Cycle** (-30 to 50°C, -38 to 60°C & -45 to 70°C, 30 cycles)
 - **Mechanical Test** (Shearing, shock, pulling)
 - **Optical test** (light yield)
- ❑ **Qualification:**
 - 1. Tooling and procedure**
 - **Thermal Cycle** (-30 to 50°C, 0-30-60 cycles)
 - **Mechanical Test** (only Shearing)
 - **Optical test** (light yield)
 - 2. Sub-contractor**
 - **Same plan**
- ❑ **Acceptance test:**
 - **2 samples every 100 bonding**
 - **100% Visual inspection** (bubble)
 - ⇒ **repair allowed but PDA lost**



Wrapping foils inspection and testing

- ❑ **VM2000 roll Acceptance:**
 - **Reflectivity measurement**
 - **Wrapping of a reference CDE for L.Y. measurement**
- ❑ **VM2000 cutting Acceptance:**
 - **Clean room environment (Class 100,000)**
 - **Packaging by 12 sheets (with traceability)**
 - **1 sheet every 120 for L.Y. control on ref CDE**

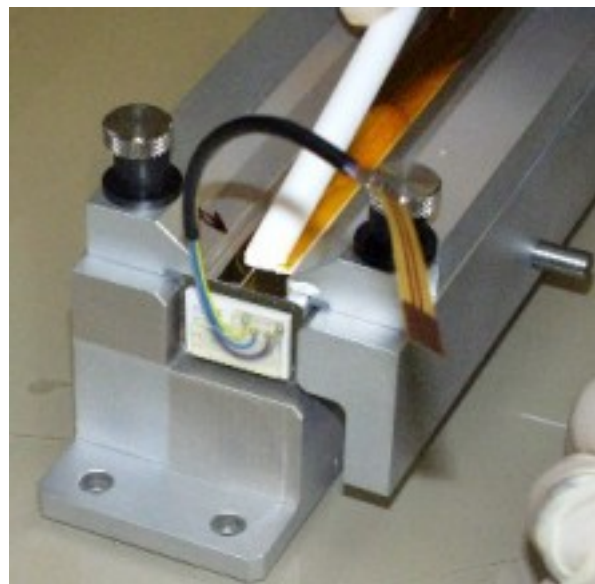


CDE Wrapping Tooling design

- Based on Swales design and procedure

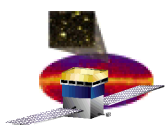
Upgrade of the molding tooling for a better reliability of the sheet position

VM2000 Mold
tooling (120°C,
2h)



Industrialization of the Wrapping tooling

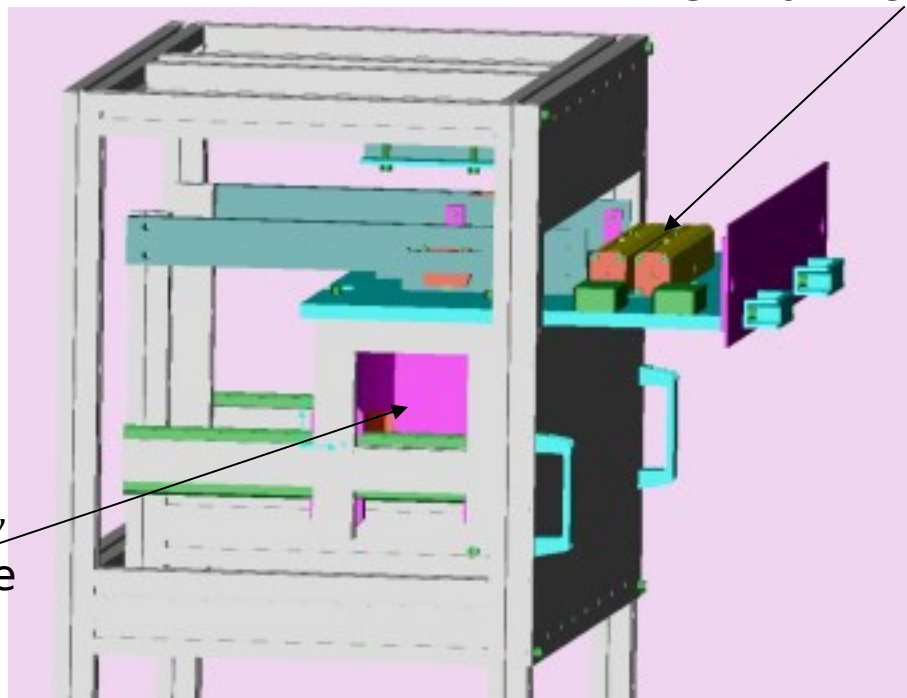
Wrapping tooling



CDE Verification Plan (1)

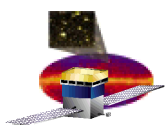
- ❑ **TEST at the subcontractor**
 - **100% mechanical control**
 - **100% PIN B L.Y. and resolution ; PIN B/PIN A ratio**

2 CDE at the time in their V support



Yttrium 1.84MeV γ
radioactive source

BIG (Banc Industrie Glast)



CDE Verification Plan (2)

□ Performance measurements before shipping to NRL

– For both PIN A & B:

- Light yield
- Resolution
- Tapering, Asymmetry

Cosmic muon (3GeV, 11MeV deposit)

2 x 6 CDE in V support

Top Hodoscope

330 mm

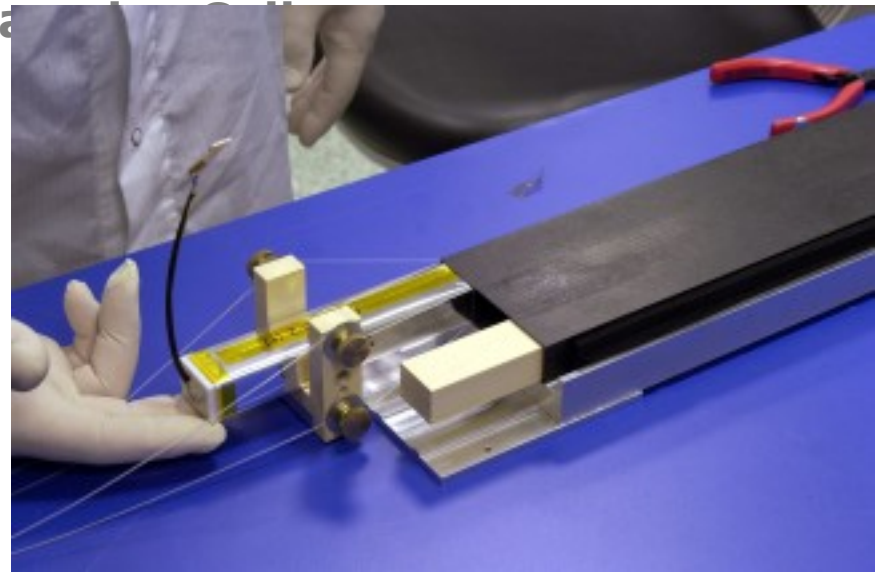
Bottom Hodoscope

BCG (Banc Cosmiques Glast)

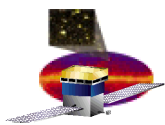


CDE Verification Plan (3)

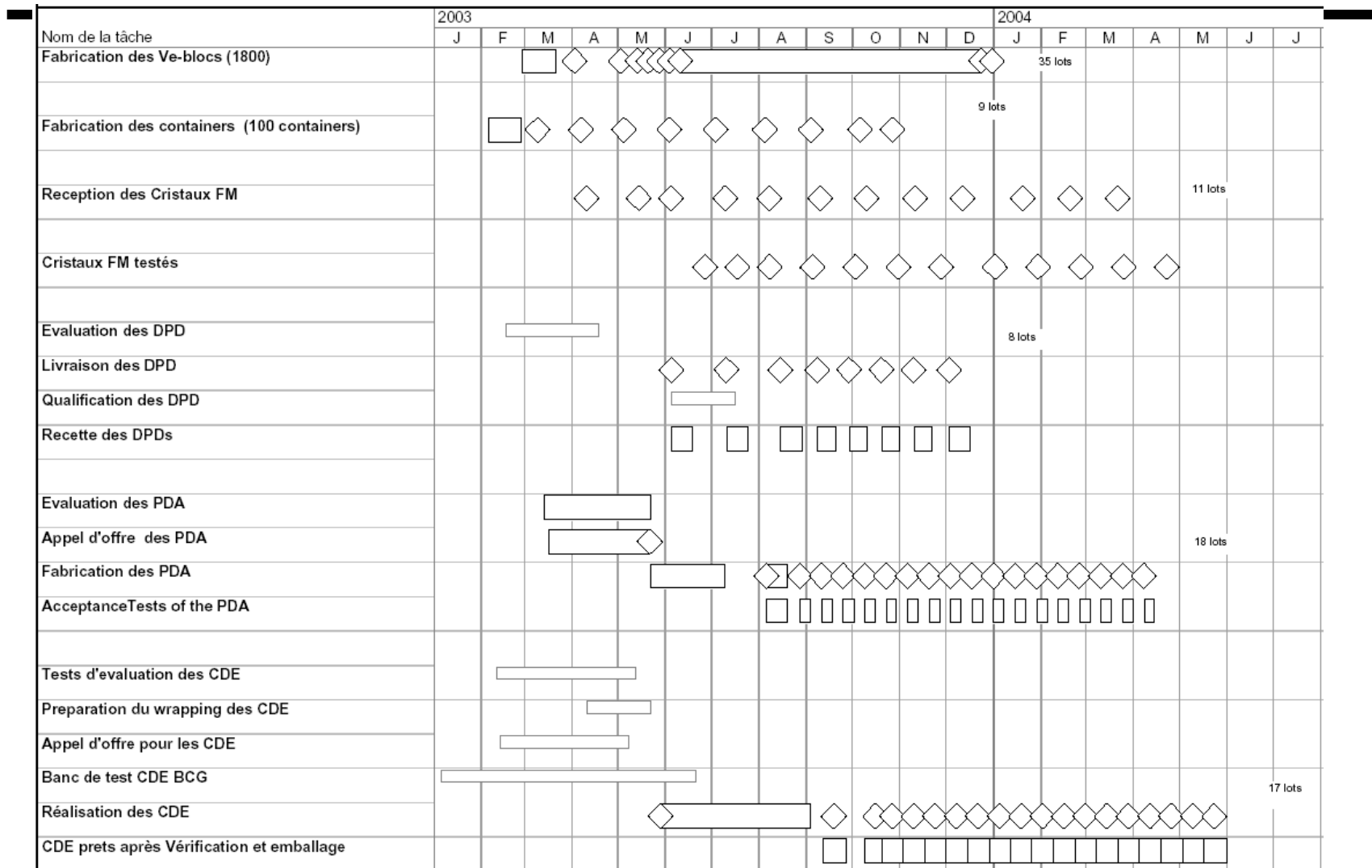
- ❑ **Insertion test before shipping to NRL**
 - **Go no go: Minimum size Cell + 1mm cord stretched by a factor 2**
 - If no go ⇒ Go-no go: Measure
 - **Study of a two pieces Aluminium Alloy Cell**



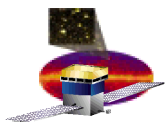
- ❑ **Qualification**
 - **Thermal Cycle** (-30 to 50°C, 0-30-60 cycles)
 - **Vacuum** (-1000mBar in 100s)
 - **Radiation test** (10kRad)



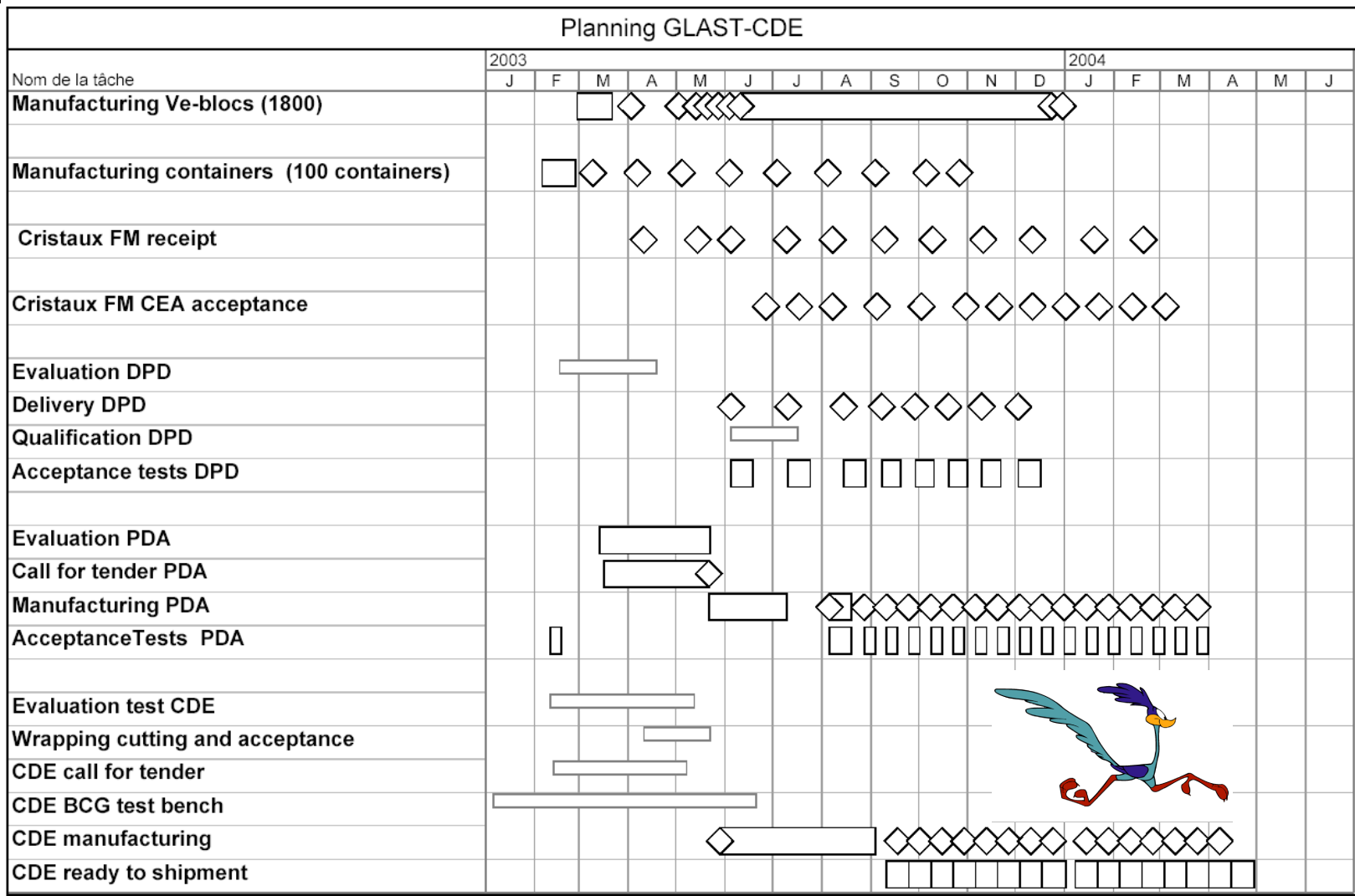
Current manufacturing schedule



Based on delivery at CEA of 184 eval DPD on April 14 and 1st FM-DPDs on June 6



Increased rate schedule



Manpower & financial impact under study (60 CDE/week)



Schedule risks

- ❑ **Current schedule very tight**
 - **assumes successful DPD evaluation, PDA qualification, & bonding qualification**
 - **Market Committee Review (Budget Ministry & CEA) : if review requested ⇒ contract starting date could shift from May 26 to June 20 **Mandatory****
 - **Manufacturers may be uncomfortable with 3 month preparation time and ask for 4 months **known on March 31****
- ❑ **Increased rate schedule**
 - **Cost impact **evaluated by March 31****
 - **Rate = 60/week ⇒ last CDE on time**
 - **Rate = 80/week ⇒ **FM4 -16 on time****



Issues/Concerns

- ❑ **New DPD evaluation**
 - in progress on 10 samples
 - on some of the 184 DPDs starting in April
- ❑ **DPD qualification on 60 DPD of lot 1 (= 600)**
 - many manufactured by then \Rightarrow risk on schedule & cost
- ❑ **PDA qualification of the soldering & staking**
 - on some of the 184 DPDs starting in April
- ❑ **Bonding qualification (concave silicon window)**
 - tests at NRL, 4 being tested at Saclay, more in April
- ❑ **Wrapping : VM2000 ESD properties**
 - in progress at NRL and Goddard
- ❑ **DPD packaging to be improved (in progress)**
- ❑ **No absolute light yield requirement on the Xtal, but on the CDE**
 - Action: L.Y. acceptance tests of Xtals with DPD and sources